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PATENT APPLICATION



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re: Application of:

Naoto SANO, et al.

Appln. No.: 09/163,402

Filed: September 30, 1998

For: GAS LASER DEVICE AND
EXPOSURE APPARATUS USING
THE SAME

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Examiner: L. Scott, Jr.
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Group Art Unit: 2828
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November 9, 2004

Mail Stop Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

SUPPLEMENT TO INFORMATION DISCLOSURE STATEMENT

Sir:

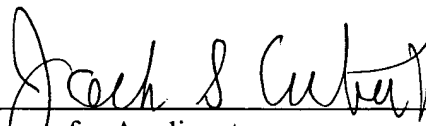
Supplemental to the Information Disclosure Statement filed October 6, 2004, a copy of the English translation of each of Japanese Laid-Open Utility Model Publication No. 63-070081 and Japanese Laid-Open Utility Model Publication No. 64-15249 are submitted.

REMARKS

Japanese Laid-Open Utility Model Publication No. 63-070081 and Japanese Laid-Open Utility Model Publication No. 64-15249 were cited in the Information Disclosure Statement filed October 6, 2004 in the above-identified application. English translations of these cited documents are enclosed herein for the use of the Examiner.

Applicants' attorney, Steven E. Warner, may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



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